

# The electroforming microfabrication of piezoelectric ejector components

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## ABSTRACT

The printer is the necessities of every family. And the inkjet printer is the mainstream of the printer at present. The inkjet print-head is the soul in the inkjet printer. Among various actuating ways, the extensively used is piezoelectric actuator. With the development of High-Tech industry, the application of inkjet printing become more extensive, such as biotechnology, optical communication component, micro-electro-mechanical system, industry of the engine, and organic LED display, etc. The study aims at the microfabrication of the vibration plate and nozzle plate used in piezoelectric-actuated microjet head by UV-LIGA technology. We propose a novel electroplating method, named double-side electroplating, to obtain the nickel plate with multilevel microstructure on both sides. Besides, the spill electroplating technology, electroplating over the photoresist mold, is utilize to obtain the nozzle and embedded flow channel.

Keywords : Piezoelectric, Micro-Jet, Electrofoming, LIGA-like

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